

F-6971 Atty. Docket No.: F-6971 Serial No.: 09/852,111 Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office (Rev. 7-80) Applicant: Seilchl HAYASHI, et al. 42-44F (F-49) INFORMATION DISCLOSURE CITATION Filing Date: May 9, 2001 Group: 2882 (Use several sheets if necessary) **U.S. PATENT DOCUMENTS Document Number** Date Name Class **Subclass** Filing Date Examiner Initial Appropriate **FOREIGN PATENT DOCUMENTS** Country Class **Subclass Translation Document Number** Yes No TRANSLATION KEY: * English Abstract. F Concise statement of relevance provided in foreign search report. Concise statement of relevance provided in specification. S Concise statement of relevance provided in IDS. P Relevant portion of reference translated. O English abstract only - copy of reference in pct search. OTHER INFORMATION DISCLOSURE CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.) 1997 - X-ray Reflectometer for the Diagnostics of Thin Films During Growth, U. Niggemeier, K. Lischka, W. M. Plotz and V. Holy, Journal of Applied Crystallography, Volume 30, Pages 905-908 DATE CONSIDERED 9/30/04 **EXAMINER** Hoon K. Song

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